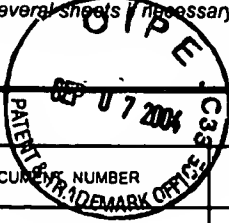


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U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

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						YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

/RK/		IBM Technical Disclosure Bulletin, FABRICATION PROCESS FOR GAS DISCHARGE PANELS by M. Berkenblit et al., Vol. 18, No. 6, November 1975, 2 pages
		EPITAXIAL GROWTH, Part A, edited by JW Matthews, IBM Thomas J. Watson Research Center, New York, Pages 91-99
/RK/		THIN FILM PROCESSES, Edited by John L. Vossen and Werner Kern, RCA Laboratories, David Sarnoff Research Center, New Jersey, 1978, Pages 340-341

EXAMINER	/Robert Kunemund/	DATE CONSIDERED	04/02/2007
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.